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Handwritten notes: 5, 14, 10-26-99, P.B.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

MIZUHARA et al. ✓

Serial No.: 09/037,674 ✓

Filed: March 9, 1998 ✓

Atty. File No.: 2933SE-11-CIP-2 ✓

For: "SEMICONDUCTOR DEVICES
PASSIVATION FILM"

) Group Art Unit: 2814

) Examiner: To be assigned

) SUPPLEMENTAL INFORMATION
) DISCLOSURE STATEMENT

CERTIFICATE OF MAILING

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SHERIDAN ROSS P.C.

BY: *[Signature]*

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Pursuant to Applicants' duty of disclosure under 37 CFR § 1.56 and 37 CFR §§ 1.97-1.98, Applicants hereby provide a copy of each of the documents identified on the enclosed PTO Form 1449, although Applicants do not admit that any of such documents, alone or in any combination, is considered to be material to patentability as defined in 37 CFR § 1.56(b). Moreover, the inclusion of these documents is not to be construed as an admission by Applicants that each such document is prior art as to the above-identified patent application.

Further pursuant to Applicants' duty of disclosure, an explanation of each such document which is not in the English language is addressed below:

Foreign Documents

1. 1-307247 -- an abstract is provided.
2. 5-226334 -- an abstract is provided.
3. 2-101532 -- The invention provides a semiconductor device that enhances the percentage content of an organic compound in an SOG film. An organic ion (e.g., CH_3^+ , CH_2H_5 and C^+) is implanted into the SOG film as shown in Fig. 1(a).
4. 2-235358 -- an abstract is provided.

Respectfully submitted,

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Date: 1/27/99